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Docket No.: M4065.0165/P165  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Garry A. Mercaldi, et al.

Application No.: 09/285,773

Group Art Unit: 1765

Filed: April 5, 1999

Examiner: L. Eronini

For: METHOD FOR ETCHING DOPED  
POLYSILICON WITH HIGH  
SELECTIVITY TO UNDOPE  
POLYSILICON

REQUEST FOR EXTENSION OF TIME

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

RECEIVED  
FEB 27 2001  
TECHNOLOGY CENTER 1700

Applicant hereby petitions for a one month extension of time to and including February 23, 2001 to respond to the Office Action mailed October 23, 2000. Our check in the amount of \$110.00 covering the fee set forth in 37 CFR 1.17(a)(1) is enclosed.

In the event that a further petition for an extension of time is required to be submitted at this time, applicant hereby petitions under 37 CFR 1.136(a) for an extension of time for as many months as are required to ensure that the above-identified application does not become abandoned.

The Commissioner is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 04-1073, under

02/27/2001 STEFFERA 00000056 09285773

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110.00 OP

Order No. M4065.0165/P165. A duplicate copy of this paper is enclosed.

Dated: February 23, 2001

Respectfully submitted,

By 

Thomas J. D'Amico

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